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39870

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MESSAGE:

Serial No.: 10/739,229 Confirmation: 1123

Applicant: Byoung Hee Cho Filed: December 18, 2003

Title: Method for Forming Gate Oxide in Semiconductor Device

Art Unit: 2812

Examiner: NHU, David Atty Docket: 29936/39870 Customer No.: 04743

Enclosed is a copy of an Amendment "A" (6 pages).

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Serial No. 10/739,229

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Atty. Docket 29936/39870

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No. : 10/739,229)	Date of Transmittal:
Confirmation: 1123)	June 2, 2005
Applicant : Byoung Hee Cho Filed : December 18, 2003)	I hereby certify that this paper and all documents referred to herein as being enclosed are being transmitted to the United States Patent and Trademark Office, Mail Stop Amendment via facsimile to facsimile number
Title: METHOD FOR FORMING GATE OXIDE IN SEMICONDUCTOR))	
DEVICE)	(703) 872-9306.
Art Unit : 2812 Examiner : NHU, David))	Mid Mada
)	Michael Muczynski
Atty Docket : 29936/39870		-
Customer No.: 04743		-

AMENDMENT "A"

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Please amend this application as specified on the following pages.